

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Osamu MATSUURA, et al.

Serial Number: Not Yet Assigned

Filed: December 24, 2003

**Customer No.: 38834**

For: FERROELECTRIC CAPACITOR, PROCESS FOR PRODUCTION THEREOF AND SEMICONDUCTOR DEVICE USING THE SAME

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

December 24, 2003

Sir:

In compliance with 37 CFR 1.56, Applicant(s) call(s) to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,  
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Enclosures: PTO-1449; References (7)

<b>INFORMATION DISCLOSURE STATEMENT PTO-1449</b>	Atty. Docket No. 032203	Serial No. New Appln.
Applicant(s): Osamu MATSUURA, et al.		
	Filing Date: December 24, 2003	Group Art Unit:

#### U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
_____	AC					
_____	AD					

#### FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
_____	AE 6-68529	03/11/94	Japan	Abstract
_____	AF 6-280023	10/04/94	Japan	Abstract
_____	AG 8-31951	02/02/96	Japan	Abstract
_____	AH 2000-40799	02/08/00	Japan	Abstract
_____	AI 2000-232102	08/22/00	Japan	Abstract
_____	AJ 2001-284549	10/12/01	Japan	Abstract
_____	AK 2002-16234	01/18/02	Japan	Abstract

#### OTHER DOCUMENTS

_____	AL	
_____	AM	
Examiner		Date Considered